



Attorney's Docket No.: 07977-046002 / US 3041/3050/3059/3063D1

1765

#29
10
3/14/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shunpei Yamazaki, et al. Art Unit : 1765
Serial No.: 09/304,523 Examiner : Robert Kunemund
Filed : May 4, 1999 Confirmation No. : 9801
Title : METHOD AND APPARATUS FOR PRODUCING SEMICONDUCTOR DEVICE

Commissioner for Patents
Washington, D.C. 20231

RESPONSE

In response to the action mailed November 27, 2002, please
consider the following remarks.

RECEIVED
FEB 12 2003
TO 1100 MAIL ROOM

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being
deposited with the United States Postal Service as first class mail with
sufficient postage on the date indicated below and is addressed to the
Commissioner for Patents, Washington, D.C. 20231.

February 27, 2003

Date of Deposit

Signature

Susan Regan

Susan Regan

Typed or Printed Name of Person Signing Certificate